

Company Name: **TRION TECHNOLOGY**

Examination Dates:
December 18-19, 2005

EQUIPMENT EXAMINATION REPORT

“ORACLE” ENHANCED CHEMICAL VAPOR DEPOSITION

SEMI S2-0703 Guidelines

WRITTEN BY		APPROVED BY	
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DATE	SIGNATURE	DATE	SIGNATURE
December 26, 2005	On file	December 26, 2005	On file